

684.3067

PATENT APPLICATION

#5a  
NEAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
: Examiner: Unassigned  
ICHIRO TANAKA )  
: Group Art Unit: Unassigned  
Application Based on )  
JP 250853/1999 :  
: )  
Filed: Herewith :  
: )  
For: TWO-DIMENSIONAL PHASE :  
ELEMENT AND METHOD OF )  
MANUFACTURING THE SAME : August 31, 2000

Commissioner for Patents  
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits of the above-identified application, please amend the application as follows.

In the Claims:

Please amend claims 2-4, 6-13 and 15 as follows:

a1  
SUB  
BI  
2. (Amended) A method of manufacturing a two-dimensional phase type element[,] comprising the steps of:  
forming[, on a substrate,] a first etching mask in  
a checkered pattern on a substrate; and